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SERIAL NUMBER 10/520,099	FILING OR 371(c) DATE 01/04/2005 RULE	CLASS 117	GROUP ART UNIT 1765	ATTORNEY DOCKET NO. 122336	
APPLICANTS Ryoji Hoshi, Fukushima, JAPAN; Susumu Sonokawa, Fukushima, JAPAN; ** CONTINUING DATA ***** This application is a 371 of PCT/JP03/08671 07/08/2003 ** FOREIGN APPLICATIONS ***** JAPAN 2002-204703 07/12/2002					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Verified and Acknowledged <i>[Signature]</i> <i>ft.</i> Examiner's Signature Initials		STATE OR COUNTRY JAPAN	SHEETS DRAWING 6	TOTAL CLAIMS 29	INDEPENDENT CLAIMS 3
ADDRESS 25944					
TITLE Silicon wafer for epitaxial growth, epitaxial wafer, and its manufacturing method					
FILING FEE RECEIVED 1350	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		